ECE 336: Semiconductor Devices Lab#4: MOSFET

Objectives

The purpose of this exercise is to analyze the properties of the MOSFET, understand the effect of each of the model parameters discussed in the exercise.

By the end of this exercise you should be able to:

- 1. Explain the effect of VT on the turn on of the MOSFET
- 2. Explain the effect of KP on the current of the MOSFET.
- 3. Explain the 2nd order effects of the MOSFET device.

Requirements and Deliverables

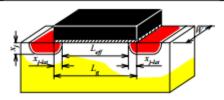
In this exercise you are required to use the MOSFET device in simulation to obtain its characteristic curves and analyze its various parameters.

You should deliver a technical report containing the following sections:

- A survey on the second order effects of MOSFET device (channel length modulation, body effect, mobility degeneration... etc)
- Procedures: A description and snapshots of the lab procedures taken from your PC,
- Results: Numerical and graphical simulation results as requested
- Comments: Your conclusion about the results and your answers for the assignment questions.

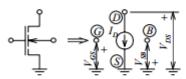
MOSFET Device model:

GEOMETRICAL VARIABLES



 $L_{eff} = L_g - 2x_{j-lat}$ (x_{j-lat} is a parameter; refer to Table 5.5)

	Symbol	SPICE	Variable Name	Default Value	Unit			
		Keyword						
	L_g	L	Gate length	100×10^{-6}	m			
	W	W	Channel width	100×10^{-6}	m			
	NOTE: L and W can also be specified as parameters							
1	STATIC LEVEL-3 MODEL							



 $\begin{array}{ll} \text{NMOS} \ (V_{Ts} = V_T + n_s kT/q) \\ \text{sub-}V_T: & V_{GS} \leq V_{Ts} \\ \text{triode:} & V_{GS} > V_{Ts}, \text{ and } 0 < V_{DS} < V_{DSsat} \\ \text{satur.:} & V_{GS} > V_{Ts}, \text{ and } V_{DS} \geq V_{DSsat} > 0 \end{array}$

 $\begin{aligned} & \text{PMOS} \ (V_{Ts} = V_T - n_s kT/q) \\ & \text{sub-}V_T \colon \quad V_{GS} \geq V_{Ts} \\ & \text{triode:} \quad V_{GS} < V_{Ts}, \text{ and } 0 > V_{DS} > V_{DSsat} \\ & \text{satur.:} \quad V_{GS} < V_{Ts}, \text{ and } V_{DS} \leq V_{DSsat} < 0 \end{aligned}$

$$I_D = \begin{cases} f(V_{GS}) = \begin{cases} \beta[(V_{GS} - V_T)V_{DS} - (1 + F_B)\frac{V_{GS}^2}{2}], & \text{triode region} \\ \frac{\beta}{2(1 + F_B)}(V_{GS} - V_T)^2, & \text{satur. region} \end{cases} \\ f(V_{GS} = V_{Ts}) \times e^{-qV_{subth}/n_skT}, & \text{sub-}V_T \text{ region} \end{cases}$$

$$V_{subth} = V_{Ts} - V_{GS} \ge 0 \qquad V_{subth} = V_{GS} - V_{Ts} \ge 0$$

 $F_B = \frac{\gamma F_s}{2\sqrt{|2\phi_F|+V_{SB}}} + F_n^{(2)}$

 $F_B = \frac{\gamma F_s}{2\sqrt{|2\phi_F|-V_{SB}}} + F_n^{(2)}$

Depletion Channel Layer Principal Related Related All

Effects Second-Order Effects

Table A.5 Table A.6 Table A.5 Table A.6 β , V_{DSsat} V_T , $|2\phi_F|$, γ , F_s , F_n , n_s Table A.5 Table A.5 Table A.7

Symbol	SPICE	Parameter Name	Typical Value	Unit
	Keyword		NMOS PMOS	
KP (or	KP	Transconductance parameter *	1.2×10^{-4}	A/V^2
μ_0 and	Uo	Low-field mobility †	700	cm^2/Vs
t_{ox})	Tox	Gate-oxide thickness †	20×10^{-9}	m
V_{T0}	Vto	Zero-bias threshold voltage	1 -1	V
$ 2\phi_F $	Phi	Surface potential in strong inversion	0.70	V
γ	Gamma.	Body-effect parameter	> 0.3	$V^{1/2}$

NMOS

PMOS

$$\beta = \left\{ \begin{array}{ll} \text{KP} \frac{\mathbf{W}}{L_{eff}} \,, & \text{if KP is specified} \\ \mu_0 \frac{\varepsilon_{ox}}{t_{ox}} \frac{\mathbf{W}}{L_{eff}} \,, & \text{if KP is not specified} \end{array} \right.$$

$$L_{pinch} = 0$$
 (KAPPA=0)

$$\begin{split} V_T = \text{Vto} + \text{Gamma} \left(\sqrt{\text{Phi} + V_{SB}} \ - \sqrt{\text{Phi}} \right) & V_T = \text{Vto} - \text{Gamma} \left(\sqrt{\text{Phi} + V_{BS}} \ - \sqrt{\text{Phi}} \right) \\ V_{DSsat} &= \frac{V_{GS} - V_T}{1 + F_B} \\ F_s &= 1 \quad (\text{Xj=0}) \\ F_n &= 0 \quad (\text{DELTA=0}) \\ n_s &= 1 + \frac{\gamma F_s (\text{ Phi} + |V_{SB}|)^{-1/2}}{2} \quad (\text{NFS=0}) \end{split}$$

...

CONSTANT: $\varepsilon_{ox} = 3.9 \times 8.85 \times 10^{-12} F/m$

Keyword			Value		
KP (or	KP	Transconductance	1.2×10^{-4}	A/V^2	
		parameter *			
μ_0 and	Uo	Low-field mobility †	700	cm^2/Vs	
t_{ox})	Tox	Gate-oxide thickness †	20×10^{-9}	m	
θ	THETA	Mobility modulation constant	0.1	-	
v_{max}	Vmax	Maximum drift velocity	10^{5}	m/s	
κ	KAPPA	Channel length modulation	0.2	-	
		coefficient (needs Nsub)			
N_A, N_D	Nsub	Substrate doping concentration		cm^{-3}	
		β and V_{DSsat} EQUATIONS	8		
NMOS PMOS					
\Rightarrow		coefficient (needs Nsub) Substrate doping concentration 10^{15} cm^{-3} β and V_{DSsat} EQUATIONS			
		$\mu_s = \frac{\mu_0}{1 + \text{THETA} V_{GS} - V_T }$			
		$\mu_0 = \mathtt{KP} \frac{\mathtt{Tox}}{\varepsilon_{ox}}$, if KP is specified; el	se $\mu_0 = \text{Uo}$		
$L_a = \sqrt{\text{KAPPA} \frac{2\varepsilon_s}{q \text{ Nsub}} V_{DS} - V_{DSsat} }$, if Vmax is not specified (1)					
L_{pi}	$_{nch} = \left\{ \left[\left(\frac{1}{2} \right)^{n} \right] \right\}$	$\left(\frac{\varepsilon_s}{q \text{ Nsub}} \frac{V_{DSsat}}{L_{eff}}\right)^2 + L_a^2 \right]^{1/2} - \frac{\varepsilon_s}{q \text{ Nsub}} \frac{ V_{DSsat} }{L_{eff}}$, if Vmax is spe	ecified	
\Rightarrow		$V_{DSsat} = \begin{cases} \frac{V_{GS} - V_T}{1 + F_B}, & \text{if Vmax is n} \\ V_{DSsat-corr}, & \text{if Vmax is s} \end{cases}$	not specified ⁽¹⁾ pecified		
V_{DS}	$V_{DSsat-corr} = V_a + V_b - \sqrt{V_a^2 + V_b^2}$ (2) $V_{DSsat-corr} = V_a - V_b + \sqrt{V_a^2 + V_b^2}$ (2)				
		$V_a = \frac{V_{GS} - V_T}{1 + F_B}$, $V_b = \frac{V_{max}L_s}{\mu_s}$	<u>:ff</u> (2)		

CHANNEL RELATED STATIC PARAMETERS

SPICE Parameter Name Typical

Typical

Unit

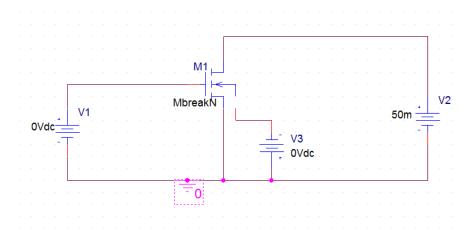
Symbol

Symbol	SPICE	Parameter Name	Typical	Unit
	Keyword		Value	
t_{ox}	Tox	Gate oxide thickness	20×10^{-9}	m
η	ETA	Static feedback	0.7	-
		NOTE: This parameter can be used with V_T and γ . t_{ox} should also be specified.		
N_A, N_D	Nsub	Substrate doping concentration	10^{15}	cm^{-3}
		NOTE: This parameter has to be specified to include the parameters below.		
N_{oc}	Nss	Oxide-charge density (needs Nsub)	10^{10}	cm^{-2}
	TPG	Gate material type (needs Nsub) - same as drain/source: $TPG = 1$ - opposite of D/S: $TPG = -1$ - Al: $TPG = 0$		•
x_{j}	Хj	P-N junction depth (needs Nsub)	0.5×10^{-6}	m
x_{j-lat}	Ld	Lateral diffusion	$0.8 \times x_j$	m
V_{bi}	PB	P-N junction built-in voltage (needs Nsub)	0.8	V
δ	DELTA	Width effect on threshold voltage	1.0	-
	NFS	Subthreshold-current fitting parameter	10^{11}	cm^{-2}

CONSTANT: $\varepsilon_{ox} = 3.9 \times 8.85 \times 10^{-12} F/m$

Procedures:

 Connect the circuit as shown in the figure, using the Mbreakn MOSFET model.



2. Edit the transistor model to LEVEL=3 KP= 20E-6 VTO=0.

- 3. Run DC sweep of V1 from 0 to 10V with 0.1V step and plot the drain current of the transistor, what is the region the transistor is operating in?
- 4. Make VTO=1 and repeat the previous step, explain the change in the output.
- 5. Make KP=100E-6 and repeat step 3, explain the change in the output.
- 6. Set GAMMA=0 and run DC sweep + parametric sweep on V3 (bulk source voltage) from 0 to 5V with step 1V.
- 7. Set GAMMA=0.6 PHI=0.75 and repeat step 6, explain why there was a change in this step not the first step? what is the name of this phenomenon?
- 8. Set GAMMA back to zero, and run **primary sweep on VDS** from 0V to 10V with 1V step and **parametric sweep on VGS from 0V to 8V** with 2V step.
- 9. Set GAMMA=0.6 PHI=0.75 and repeat the step 8 and compare the saturation current levels (what is the condition of saturation?) and exlain the results.
- 10. Run DC sweep on VGS from 0V to 10V with 1V step and run with it parametric sweep on the parameter THETA = 0 0.1, comment on the results.
- 11. Repeat step 8 and 9 but this time **change the parameter THETA** (**not gamma**) **to 0 and 0.1**, explain the results.